Electronic Acknowledgement Receipt				
EFS ID:	1079728			
Application Number:	10827276			
Confirmation Number:	2653			
Title of Invention:	Method for fabricating mesh of tetracde field-emission display			
First Named Inventor:	Shie-Heng Lee			
Correspondence Address:	YI-Wen Tseng - 4331 Stevens Battle Lane - Fairfax VA 22033 US -			
Filer:	Kao Lu/Chun-Ming Shih			
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Attorney Docket Number:	OP-093000176			
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no

Submitted with Payment

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	Amd.pdf	53555	no	6
Warnings:		A 0 0			
Information:					
2	Power of Attorney (may include Associate POA)	POA.pdf	30682	no	1

Warnings:

Information:

Total Files Size (in bytes):

84237

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.